Interface quality and thermal stability of laser-deposited metal/MgO multilayers


Metal/MgO multilayers (metal of Fe, Ni$_{80}$Nb$_{20}$, and Ti) with bilayer periods in the range 1.2–3.0 nm have been prepared by pulsed laser deposition and characterized by both hard and soft-x-ray reflectometry. The interface roughness is found to be ≤0.5 nm in all the samples and is nearly independent of the total number of deposited bilayers. The interface roughness, however, depends on the absolute thickness of the individual layers and increases from ~0.3 nm for a 3.0-nm period to ~0.5 nm for a bilayer period of 1.2 nm. The multilayers are found to be highly stable up to temperatures as high as 550 °C. The hard-x-ray reflectivity of the multilayers decreases for $T > 300$ °C, whereas the layered structure is stable up to 550 °C. The reflectivity in the water window region of soft x rays, $\lambda = 3.374$ nm, was found to be 0.4% at an angle of incidence of ~54° for multilayers with 60 bilayers at a period of ~2.1 nm. © 2004 Optical Society of America


1. Introduction

The physical properties of multilayers with individual layer thicknesses in the nanometer range depend critically on the nature of the interfaces. Hence a study of interface roughness and its development becomes highly significant. In particular, the reflectivity of multilayer mirrors is attenuated by interface roughness, which has two distinct components—morphological roughness and intermixing. In the case of vapor-phase condensation, the morphological roughness depends on the surface mobility of the condensing particles, a function of their energy, and the rate of deposition. The condensing particles should have sufficient energy for surface movement to form a smooth surface. An excess energy for the condensing particles on the other hand can lead to implantation or intermixing. Hence control of the energy of the condensing particles becomes crucial for the deposition of multilayers with smooth interfaces, and pulsed laser deposition becomes a suitable technique for this purpose. Pulsed laser deposition offers the additional advantage of stoichiometric transfer of both alloys and oxides. Hence this technique has been used in the present study to prepare multilayers for the water window region of soft x rays ($\lambda = 2.3–4.4$ nm). The stability of multilayers and the interface roughness depend on interdiffusion between individual components, and this has to be minimized to maximize the thermal and temporal stability.

The selection of materials for the multilayer constituents in the present study is done based on the dual purpose of water window soft-x-ray mirrors and by maximization of the thermal and temporal stability. One of the suitable spacer elements for the water window region is Mg. However, since it is highly unstable and reactive, the more stable MgO has been used as spacer material together with absorbers Ni$_{80}$Nb$_{20}$ and Fe. A survey of the optical constants of various materials indicates that Ti is an excellent spacer for wavelengths slightly above that of its L-absorption edge at $\lambda = 2.73$ nm. In this case MgO becomes the absorber. We determined the interface quality using both hard and soft x rays. The thermal stability of the multilayers up to 600 °C in an ultrahigh-vacuum (UHV) environment has been investigated by hard-x-ray reflectivity.

2. Experimental Methods

All the multilayers were deposited at room temperature in an UHV chamber (base pressure $<10^{-8}$
density of 110 mJ, repetition rate 3–10 Hz
length 248 nm, pulse duration 30 ns, pulse energy

The structure of all the multilayers was first charac-
terized by hard-x-ray measurements

The substrates were cut from standard Si (111) and
(001) single-crystal wafers with a native surface ox-
ide layer. The multilayers deposited on the two
types of substrate did not show any difference in the
crystalline orientation or in the interface roughness,
indicating that the substrate orientation does not in-
fluence the structure of the deposited film. Hence no
reference is made to the crystallographic orientation
of the substrate in our discussion of the results. The
multilayers were deposited with MgO as the first
layer on the substrate and a metal layer as the top
layer. The multilayers were assumed to be oxidized. The results of the simulations
have bulk densities, and the top metal layer is as-
sumed to be identical, which means that the rough-
ness at all the interfaces and a roughness that is
independent of the total number of bilayers in the
multilayer. The simulated curves yield interface
roughnesses increasing from 0.35 nm for \( \Lambda = 2.4 \) nm to 0.5 nm for \( \Lambda = 1.2 \) nm. Furthermore, metal
layer thickness to bilayer period ratios (\( \Gamma \)) between
0.3 and 0.7 are determined (Table 1).

The dependence or independence of \( \sigma \) on the num-
ber \( N \) of deposited bilayers was studied systemati-
cally in Fe/MgO multilayers. The bilayer period \( \Lambda \) was kept nearly constant between 2.1 nm and 2.2 nm, and the number of deposited bilayers increased from

For deposition, a KrF excimer laser (wave-
length 248 nm, pulse duration 30 ns, pulse energy
110 mJ, repetition rate 3–10 Hz) was focused onto an
area of approximately 2 mm\(^2\) leading to an energy
density of \( \approx 5.5 \) J/cm\(^2\) on the targets (Fe, Ni\(_{80}\)Nb\(_{20}\),
Ti, and MgO).

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multilayers were deposited with MgO as the first
layer on the substrate and a metal layer as the top
layer.

We carried out the hard-x-ray reflectivity measure-
ments with a Philips XPert diffractometer using Co
K\(_\alpha\) (\( \lambda = 0.179\) nm) radiation. We studied the thermal stability of the multilayers by annealing for 75
min in the temperature range of 200 °C to 600 °C in
the UHV environment. The structure following each annealing was determined by hard-x-ray reflect-
tometry. The reflectivity in the water window re-

<table>
<thead>
<tr>
<th>Sample</th>
<th>( N^a )</th>
<th>( \Lambda ) (nm)(^b )</th>
<th>( \sigma ) (nm)(^c )</th>
<th>( \Gamma^d )</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ni(<em>{80})Nb(</em>{20})/MgO (Fig. 1)</td>
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</tr>
<tr>
<td>(a)</td>
<td>40</td>
<td>2.36</td>
<td>0.35</td>
<td>0.70</td>
</tr>
<tr>
<td>(b)</td>
<td>40</td>
<td>2.18</td>
<td>0.35</td>
<td>0.50</td>
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<tr>
<td>(c)</td>
<td>40</td>
<td>1.46</td>
<td>0.52</td>
<td>0.33</td>
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<td>(d)</td>
<td>40</td>
<td>1.38</td>
<td>0.51</td>
<td>0.30</td>
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<tr>
<td>(e)</td>
<td>40</td>
<td>1.19</td>
<td>0.50</td>
<td>0.50</td>
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<tr>
<td>Fe/MgO (Fig. 2)</td>
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<tr>
<td>(a)</td>
<td>20</td>
<td>2.20</td>
<td>0.33</td>
<td>0.38</td>
</tr>
<tr>
<td>(b)</td>
<td>55</td>
<td>2.11</td>
<td>0.35</td>
<td>0.37</td>
</tr>
<tr>
<td>(c)</td>
<td>65</td>
<td>2.14</td>
<td>0.40</td>
<td>0.21</td>
</tr>
<tr>
<td>Ti/MgO (Fig. 3)</td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>(a)</td>
<td>36</td>
<td>1.50</td>
<td>0.20</td>
<td>0.50</td>
</tr>
<tr>
<td>(b)</td>
<td>38</td>
<td>1.35</td>
<td>0.33</td>
<td>0.50</td>
</tr>
</tbody>
</table>

\(^a\) \( N \), number of bilayers.
\(^b\) Multilayer period.
\(^c\) rms roughness.
\(^d\) Ratio of metal layer thickness to bilayer period.

The presence of clear first-order Bragg peaks even
in Fe\(_{80}\)Ni\(_{20}\) multilayers is shown in Fig. 1.

The experimental hard-x-ray reflectivity curves
together with the best-fit simulations for the
Ni\(_{80}\)Nb\(_{20}\)/MgO multilayers are shown in Fig. 1. The bilayer period varies from 1.19 to 2.36 nm.
The presence of clear first-order Bragg peaks even
for a period of 1.19 nm shows that pulsed laser
deposition can be used effectively for the deposition
of ultrathin layers. The interface roughness \( \sigma \) is
\( \leq 0.5 \) nm in all cases. The sharp Bragg peak with
a low width indicates a high correlation of rough-
ness at all the interfaces and a roughness that is
independent of the total number of bilayers in the
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roughnesses increasing from 0.35 nm for \( \Lambda = 2.4 \) nm to 0.5 nm for \( \Lambda = 1.2 \) nm. Furthermore, metal
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3. Results and Discussion

A. Hard-X-Ray Reflectivity

The structure of all the multilayers was first charac-
terized by hard-x-ray measurements (see Figs. 1–3).
The reflectivity scans show clear total thickness oscil-
lations (Kiessig fringes) and sharp multilayer
Bragg peaks indicating the presence of a well-ordered
layered structure. The bilayer period \( \Lambda \) of the mul-
tilayers can be determined from the angular position
of the Bragg peaks. To determine the other struc-
tural parameters such as the individual layer thick-
ness and the interface roughness \( \sigma \), the reflectivity
has to be simulated by standard optical formalism.

In the present study we performed the reflectivity
simulation using IMD software\(^4\) assuming a Gaussian
distribution of interface height fluctuations. The height fluctuations of the two interfaces are assumed
to be identical, which means that the rough-
ness of the two interfaces will be the same. The
individual layers in the multilayer are assumed to
have bulk densities, and the top metal layer is as-
sumed to be oxidized. The results of the simulations
that are the best fit to experimental reflectivity data
are given in Table 1 and shown in Figs. 1–3 for all the
different multilayers.

The experimental hard-x-ray reflectivity curves
together with the best-fit simulations for the
Ni\(_{80}\)Nb\(_{20}\)/MgO multilayers are shown in Fig. 1. The bilayer period varies from 1.19 to 2.36 nm.
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ber \( N \) of deposited bilayers was studied systemati-
cally in Fe/MgO multilayers. The bilayer period \( \Lambda \) was kept nearly constant between 2.1 nm and 2.2 nm, and the number of deposited bilayers increased from
20 to 65. The reflectivity curves together with the simulations are shown in Fig. 2. The interface roughness determined from the simulations increases only slightly from 0.33 to 0.40 nm when the number of bilayers increases from 20 to 65 (see Table 1). These results clearly show that \( \sigma \) does not scale with \( N \) and reaches a saturation. In the case of Ti/MgO multilayers, (Fig. 3), the interface roughness is found to be even lower than in Fe/MgO and Ni\(_{80}\)Nb\(_{20}\)/MgO multilayers. The value of \( \sigma \) in 1.35-nm period Ti/MgO multilayers is \( 0.33 \) nm whereas for a comparable Ni\(_{80}\)Nb\(_{20}\)/MgO multilayer with a period of 1.38 nm the interface roughness is \( 0.50 \) nm. These results show that the growth behavior of Ti is different compared with Fe or Ni\(_{80}\)Nb\(_{20}\).

A comparison of the interface roughness values for the multilayers given in Table 1 shows that \( \sigma \) increases with decreasing \( \Lambda \) (see Fig. 4). This behavior is contrary to the growth behavior observed by Mertins et al.\(^5\) and Schäfers et al.\(^6\) who grew the multilayers using a sputtering technique. It can be concluded from the present observations that an ultrathin-film growth mechanism in UHV pulsed laser deposition is very different from that in sputter deposition.

**B. Soft-X-Ray Reflectivity**

The soft-x-ray reflectivity of typical Ni\(_{80}\)Nb\(_{20}\)/MgO and Fe/MgO multilayers was measured at a wavelength of 3.374 nm provided by a line-emitting laser-plasma source. Since this wavelength is not ideal for Ti-based multilayers (the L-absorption edge is at 2.73 nm), the soft-x-ray reflectivity of these multilayers was not measured. Figure 5 shows the reflectivity of a 60-bilayer, 2.11-nm period Ni\(_{80}\)Nb\(_{20}\)/MgO

![Fig. 1. Hard-x-ray reflectivity of Ni\(_{80}\)Nb\(_{20}\)/MgO multilayers as a function of the bilayer period varied in the range from 2.36 to 1.91 nm, ([a]–[e]) showing clear total thickness oscillations and the layer period Bragg peak (solid curves). The number of bilayers is kept constant at 40. A simulation of the reflectivity (dashed curves) gives the interface roughness variation with the period. The curves are shifted vertically for clarity.](image1)

![Fig. 2. Hard-x-ray reflectivity of Fe/MgO multilayers as a function of varying number: (a) 20, (b) 55, and (c) 65. Periods between 2.1 and 2.2 nm show clear peaks and hence a complete layer ordering. The results of our simulations (dashed curves) are also shown. The curves are shifted vertically for clarity.](image2)

![Fig. 3. Measured (solid curves) and simulated (dashed curves) hard-x-ray reflectivity of Ti/MgO multilayers with (a) 1.50-nm and (b) 1.35-nm periods. A simulation of reflectivity shows that the interface roughness is 0.20 and 0.33 nm, respectively. The curves are shifted vertically for clarity.](image3)

![Fig. 4. Summary of the rms interface roughness values \( \sigma \) measured on Ni\(_{80}\)Nb\(_{20}\)/MgO, Fe/MgO, and Ti/MgO multilayers with bilayer period \( \Lambda \).](image4)
multilayer, and the reflectivity of a 65-bilayer, 2.14-nm period Fe/MgO multilayer is shown in Fig. 6. The absolute reflectivity in both cases is found to be $\sim 0.4\%$, a relatively high value considering that the individual layers' thickness was not optimized and that there were only approximately 60 bilayer pairs.

C. Thermal Stability

The usability of multilayers for any application depends on their stability with respect to temperature and time. Hence the thermal stability of typical Ni$_{80}$Nb$_{20}$/MgO and Fe/MgO multilayers in the range 200 °C–600 °C has been studied with hard-x-ray reflectivity. The results of annealing for 75 min at different temperatures are shown in Figs. 7 and 8.

The results show that both types of multilayer are highly stable up to temperatures of $\sim 550$ °C. The layered structure can be clearly seen by the well-defined first-order Bragg peaks. The bilayer Bragg peaks vanish after annealing at 600 °C, revealing severe interdiffusion and roughening leading to a breakdown of the layered structure. The position and height of the first-order Bragg peak changes when annealed at temperatures in the range 200 °C–300 °C. The bilayer period is found to decrease slightly, 1%–2%, and the first-order Bragg peak reflectivity increases compared with the as-deposited state (Fig. 7). These results are in agreement with the results of Vitta and Yang, where improved reflectivity was found after annealing Ni-Nb/C multilayers due to atomic relaxation processes. Although the layered structure is present till 550 °C, the reflectivity decreases for $T > 300$ °C, as can be seen in Fig.
9, indicating this to be the onset temperature for severe interdiffusion and roughening.

4. Conclusion

Three different types of multilayer mirrors for the water window soft-x rays with two different absorber and spacer combinations have been made with periods in the range of 1.19–2.36 nm. In the case of Ni<sub>80</sub>Nb<sub>20</sub>/MgO and Fe/MgO multilayers, MgO is the spacer; and in the Ti/MgO multilayers, it acts as the absorber because of its optical constants in comparison with Ni<sub>80</sub>Nb<sub>20</sub>, Fe, and Ti.

The interface roughness increases with a decreasing period and is found to be ≤0.5 nm even in the lowest period multilayer. This is due to the deposition process that provides sufficient energy for the condensing particles to move freely on the surface to smoothen it but not enough to lead to intermixing.

The low roughness results in a relatively high soft-x-ray reflectivity at high angles of incidence. Optimizing the absorber and spacer thickness can lead to significant improvements in soft-x-ray reflectivity.

The Ni<sub>80</sub>Nb<sub>20</sub>/MgO and Fe/MgO multilayers have a very high thermal and temporal stability as can be seen from the annealing results. The layered structure is stable even after annealing for 75 min at 550 °C. This is due to the lack of an interdiffusion potential between the ceramic MgO layers and the respective metal layers. MgO is highly stable and can only undergo roughening with very little interdiffusion. This suggests that the multilayers with MgO as one of the constituents can take substantial heat load even when used with intense synchrotron radiation.

References